

PTO-1449 Information Disclosure Citation in an Application				Application No.		Applicant(s)	
				10/735,477		David C. Hovda	
				Docket Number		Group Art Unit	Filing Date
				S-16		3739	December 11, 2003
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A.	5,098,431	03/24/92	Rydell	606	48	07/03/90
	B.	5,122,138	06/16/92	Manwaring	606	46	11/28/90
	C.	5,417,687	05/23/95	Nardella et al.	606	32	04/30/93
	A.	6,261,286	07/17/01	Goble et al.	606	34	10/16/98
	B.	6,261,311	07/17/01	Sharkey et al.	607	96	7/30/99
	C.	6,264,652	07/24/01	Eggers et al.	606	41	05/18/99
	D.	6,277,112	08/21/01	Underwood et al.	606	32	02/20/98
	E.	6,280,441	08/28/01	Ryan	606	45	12/15/97
	A.	6,749,604	06/15/04	Eggers et al.	606	41	03/30/00
	B.	6,770,071	8/3/2004	Woloszko et al.	606	41	2/9/2001
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	B.	7,179,255	02/20/07	Lettice et al.	606	32	12/20/00
	C.	7,186,234	03/06/07	Dahla et al.	604	22	02/05/02
	D.	7,192,428	03/20/07	Eggers et al.	606	41	03/20/03
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	E.	7,217,268	05/15/07	Eggers et al.	606	32	06/24/03
	G.	4,573,448	3/4/86	Kambin	606	170	10/5/1983
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	L.	6,746,451	6/8/04	Middleton et al.	606	79	6/1/2001
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	N.	7,108,696	9/19/06	Daniel et al.	606	41	9/22/2003
EXAMINER					DATE CONSIDERED		
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	A.	2003/0014047	1/16/2003	Woloszko et al.	606	41	6/18/2002
	B.	2002/0029036	03/07/02	Goble et al.	606	38	08/09/01
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	A.	05/000434	12/20/06	NL	---	---	X
	B.	05/125287	12/29/05	WO	A61B	18/00	X
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	B.	Stoffels, E. et al., "Investigation on the Interaction Plasma-Bone Tissue", E-MRS Spring Meeting, 1 pg					06/18-21/2002
	C.	Stoffels, E. et al., "Biomedical Applications of Plasmas", Tutorial presented prior to the 55 th Gaseous Electronics Conference in Minneapolis, MN, 41 pgs					10/14/02
	D.	Stoffels, E. et al., "Plasma Interactions with Living Cells", Eindhoven University of Technology, 1 pg					2002
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	G.	Stoffels, E. et al., "Plasma Physicists Move into Medicine", Physicsweb, 1 pg					11/2003
	H.	Stoffels, E. et al., "Plasma Treated Tissue Engineered Skin to Study Skin Damage", Biomechanics and Tissue Engineering, Materials Technology, 1 pg					2003
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A.		Stoffels, E. et al., "Plasma Treatment of Dental Cavities: A Feasibility Study", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1540-1542			08/2004
B.		Stoffels, E. et al., "The Effects of UV Irradiation and Gas Plasma Treatment on Living Mammalian Cells and Bacteria: A Comparative Approach", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1544-1550			08/2004
C.		Stoffels, E. et al., "Electrical and Optical Characterization of the Plasma Needle", New Journal of Physics 6, pp. 1-14			10/28/04
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J.		Stoffels, E. et al., "Killing of S. Mutans Bacteria Using a Plasma Needle at Atmospheric Pressure", IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1317-1324			08/2006
K.		Stoffels, E. et al., "Plasma-Needle Treatment of Substrates with Respect to Wettability and Growth of Escherichia Coli and Streptococcus Mutans", IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1325-1330			08/2006
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